Grinding fluid composition

Patent number:

CN1384170

Publication date:

2002-12-11.

Inventor:

YOSHIGYO OSHIMA (JP)

Applicant:

KAO CORP (JP)

Classification:

- international:

C09G1/02; C09K3/14; C09G1/00; C09K3/14; (IPC1-7):

C09K3/14

- european: C09G1/02; C09K3/14D2

Application number: CN20020118591 20020426

Priority number(s): JP20010133650 20010427

Also published as:

US6818031 (B2) US2002194789 (A1) JP2002327170 (A) CN1187427C (C)

Report a data error here

Abstract not available for CN1384170 Abstract of corresponding document: US2002194789

A polishing composition comprising an abrasive, an oxidizing agent, a polishing accelerator, and water, wherein the polishing accelerator comprises an organic phosphonic acid; a method for manufacturing a substrate, comprising polishing a substrate to be polished with the above polishing composition; a method for polishing a substrate comprising polishing a substrate to be polished with the above polishing composition; a process for reducing fine scratches of a substrate, comprising polishing a substrate to be polished with the above polishing composition; and a process for accelerating polishing of a magnetic disk substrate, comprising applying the above polishing composition to a magnetic disk substrate to be polished. The polishing composition is highly suitable for polishing a magnetic disk substrate requiring high surface quality to be used in memory hard disk drives.

Data supplied from the esp@cenet database - Worldwide